

PTO/SB/08A (08-00)

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of

Application Number

Filing Date

First Named Inventor

BOYLE, Adrian

Group Art Unit

Examiner Name

Attorney Docket Number

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**Examiner
Signature**

/Shamim Ahmed/ (02/12/2007)

Date Considered

02/12/2007

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SA		LIM P ET AL, "Laser-Assisted Liquid Film Etching", Applied Physics Letters, American Institute of Physics, New York, US, vol. 62, no.25, 21 June 1993, pages 3345-3347, XP000380997, ISSN: 0003-6951, page 3345	
SA		DATABASE WPI, Section Ch, Week 198637, Derwent Publications Ltd., London, GB: Class L03, AN 1986-240798 XP02261883 & JP 61 053731 A (ANRITSU ELECTRIC CO LTD), 17 March 1986, abstract; figure 1	
SA		SVORCIK V ET AL: "Laser-Stimulated Etching of N-Si in aqueous solutions" Material Letters, North Holland Publishing Company, Amsterdam, NL, vol.9, no.5/6, 1 March 1990, pages 204-206 XP000127337, ISSN: 0167-577X, the whole document	
SA		Patents Abstracts of Japan, vol. 012, no. 330 (E-655), 7 September 1988 & JP 63 094657 A (NEC CORP), 25 April 1988,	

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